Electronic Patent Application Fee Transmittal						
Application Number:	10699079					
Filing Date:	31-Oct-2003					
Title of Invention:	Composition and method for low temperature deposition of silicon-containing films					
First Named Inventor/Applicant Name:	Ziyun Wang					
Filer:	Steven John Hultquist					
Attorney Docket Number:	ATMI-594-CIP					
Filed as Large Entity						
Utility Filing Fees						
Description	Fee Code Quantity Amount Sub-Total in USD(\$)					
Basic Filing:						
Pages:						
Claims:						
Miscellaneous-Filing:						
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
Extension-of-Time:						

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Miscellaneous:						
Request for continued examination	1801	1	810	810		
	Total in USD (\$)			810		